

A STRUCTURE OF A MICRO ELECTRO MECHANICAL SYSTEM AND THE  
MANUFACTURING METHOD THEREOF

Inventor: Wen-Jian LIN

Docket No. 4006-284

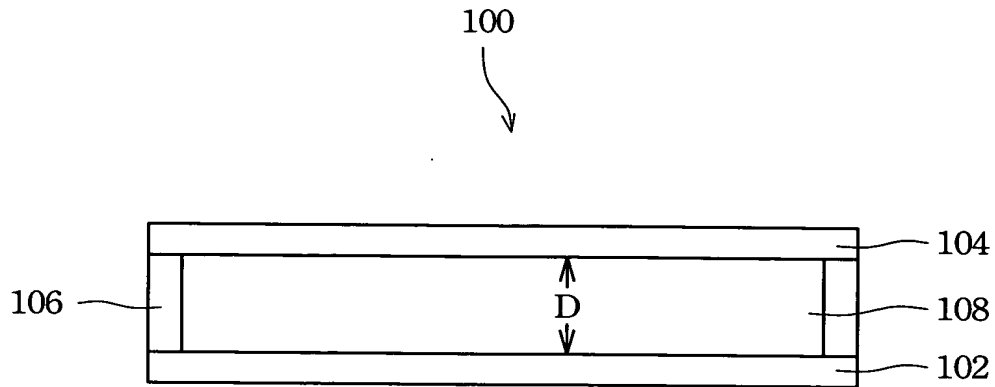


FIG.1 (PRIOR ART)

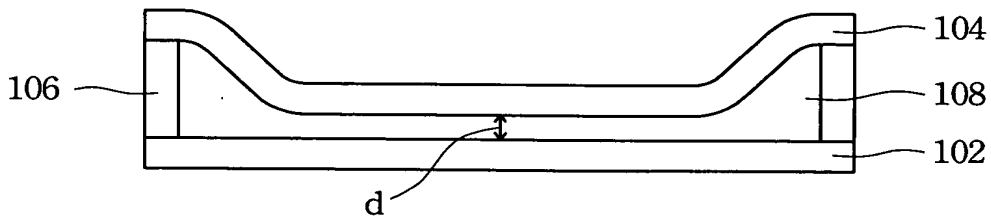


FIG.2 (PRIOR ART)

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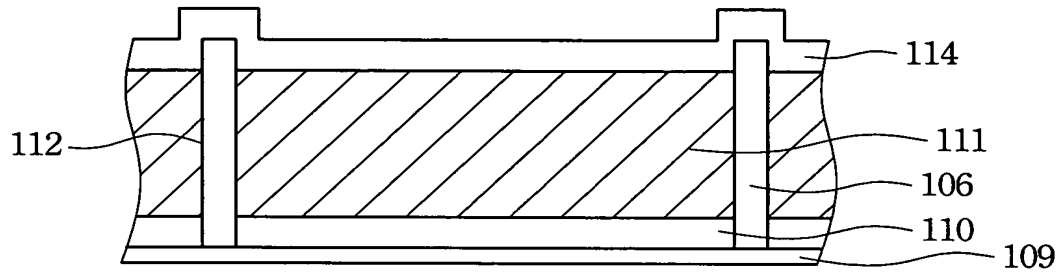


FIG.3A (PRIOR ART)

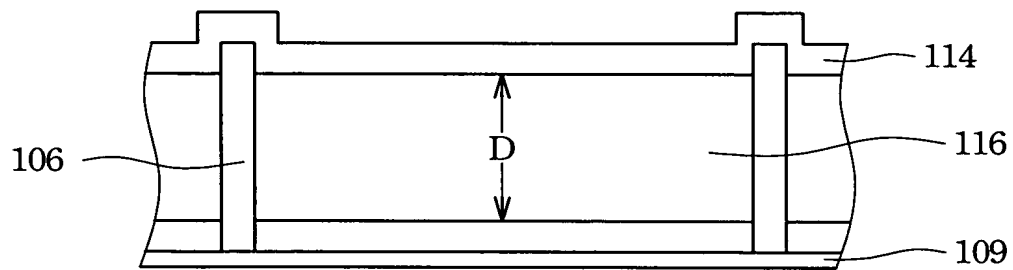


FIG.3B (PRIOR ART)

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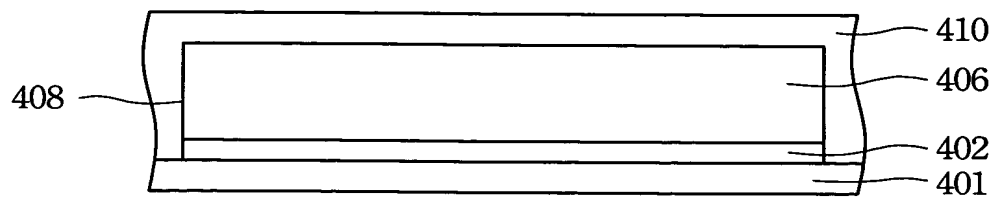


FIG. 4A

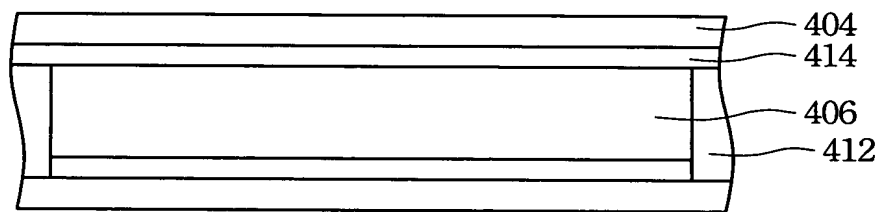


FIG. 4B

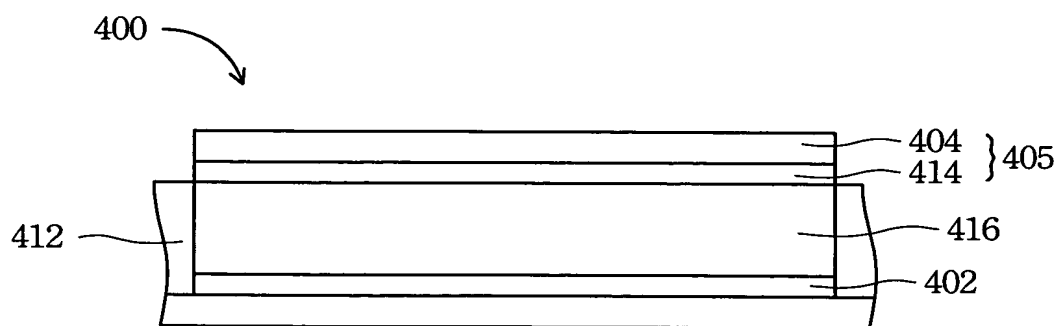


FIG. 4C

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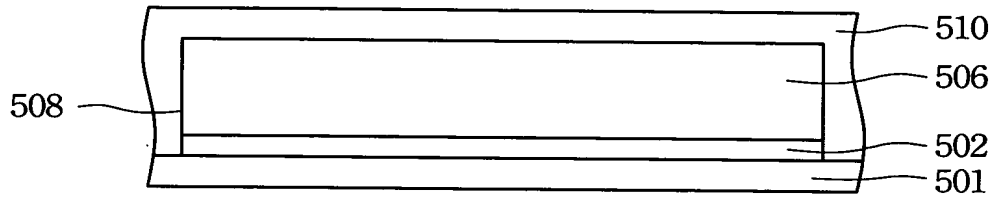


FIG. 5A

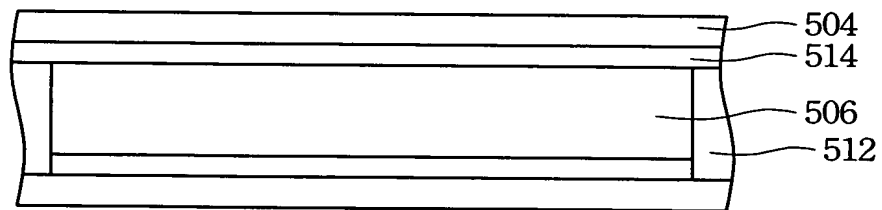


FIG. 5B

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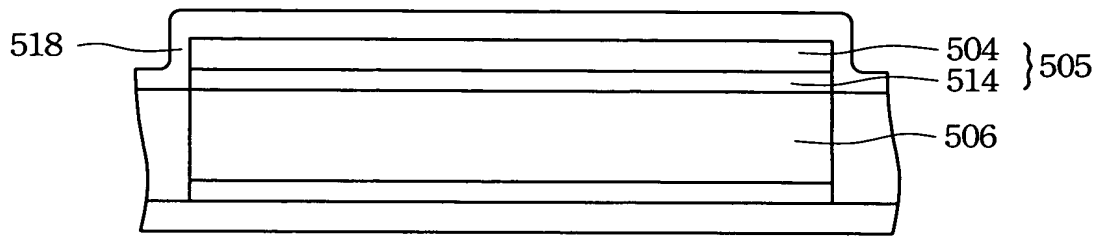


FIG. 5C

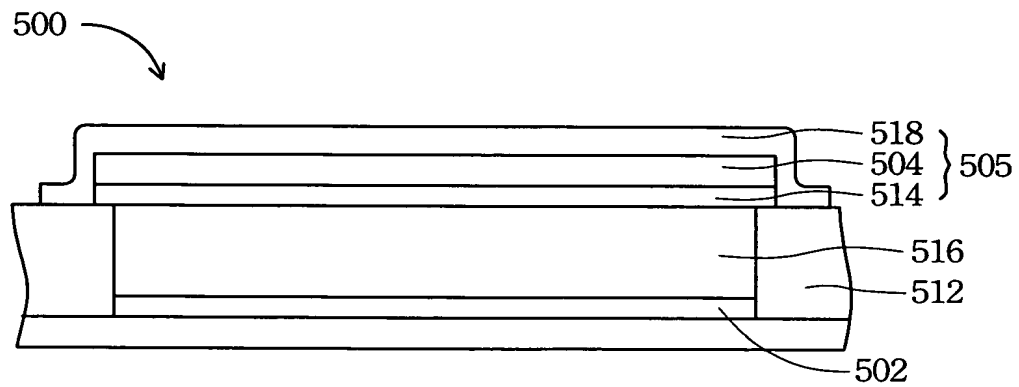


FIG. 5D

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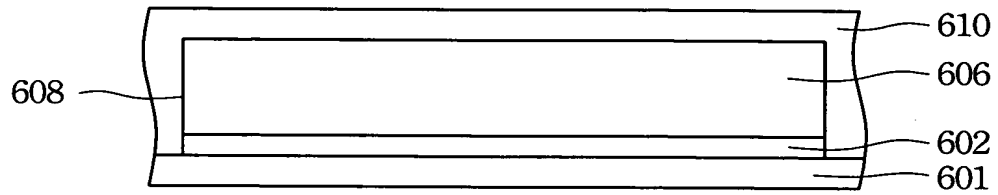


FIG. 6A

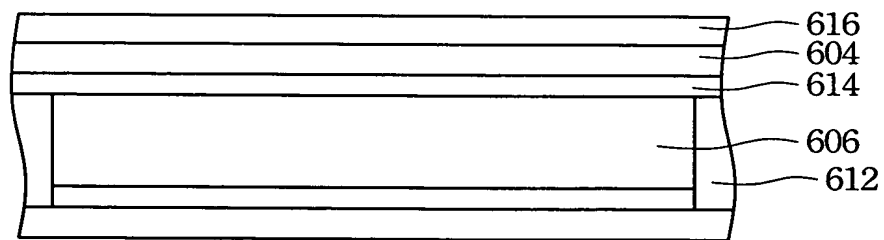


FIG. 6B

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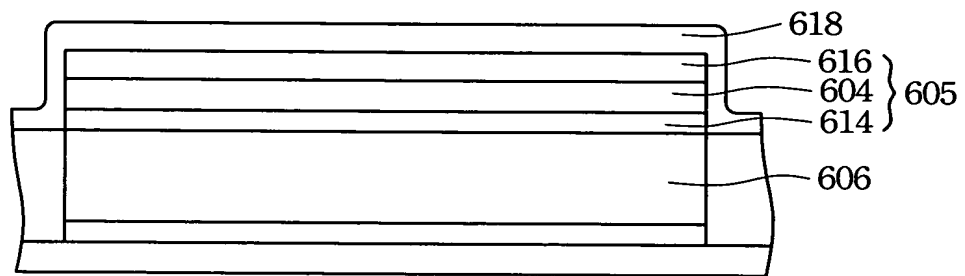


FIG. 6C

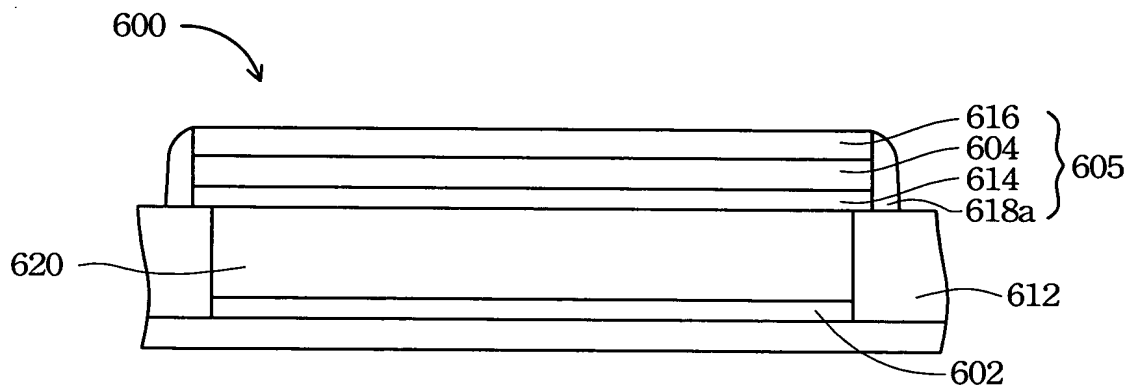


FIG. 6D